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8/17/01
Harris

PATENT APPLICATION
Attorney Docket No. D/98779I3

CERTIFICATE OF MAILING

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Patricia Kocsis
Patricia Kocsis

8.7.01
Date August 8, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:	Kneissl et al.	Date:	August 7, 2001
Serial No.:	09/277,328	Group:	2813
Filed:	March 26, 1999	Examiner:	L. Schillinger
Title:	METHOD FOR NITRIDE BASED LASER DIODE WITH GROWTH SUBSTRATE REMOVED		

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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Official Action dated March 7, 2001, please amend
the above identified application as follows:

IN THE CLAIMS:

Please substitute the following for claims 1, 3, 5, 6, 9, 10 and 13.

- Sub B17
A
1. A method for making a nitride laser diode array structure
comprising the operations of:
- A